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**Microbeam analysis — Analytical  
electron microscopy — Method for the  
determination of energy resolution  
for electron energy loss spectrum  
analysis**

*Analyse par microfaisceaux — Microscopie électronique analytique  
— Méthode de détermination de la résolution énergétique pour  
l'analyse spectrale de la perte d'énergie des électrons*

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## Foreword

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The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see [www.iso.org/directives](http://www.iso.org/directives)).

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This document was prepared by Technical Committee ISO/TC 202, *Microbeam analysis*, Subcommittee SC 3, *Analytical electron microscopy*.

A list of all parts in the ISO 23420 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at [www.iso.org/members.html](http://www.iso.org/members.html).

## Introduction

In order to understand the chemical composition, the atomic bonding and the electronic structure, electron energy loss analysis is often performed with the scanning transmission electron microscope or the transmission electron microscope (S/TEM) equipped with the electron energy loss (EEL) spectrometer.

In the analysis using EEL spectrometer system, the energy loss of incident electrons by the inelastic interaction via phonon and plasmon excitations, intra- and inter-band transitions and the inner shell ionization can be measured. The inner shell ionization is particularly useful and important as it gives the information on chemical composition of materials. For the precise analysis based on the energy loss peak decomposition and its energy shifts, it is vitally important to understand the energy resolution of the EEL spectrometer system. However, the determination method of the energy resolution is not standardized yet.

This document provides the procedures for energy step calibration and energy resolution determination useful for the electron energy loss spectrum analysis in the S/TEM equipped with the EEL spectrometer.

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